



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of:

Junji ICHIMIYA

Serial No.

10/701,249

Date Filed

November 4, 2003

For

LAYOUT DESIGN METHOD FOR SEMICONDUCTOR INTEGRATED CIRCUIT, AND SEMICONDUCTOR INTEGRATED

CIRCUIT

1185 Avenue of the Americas New York, New York 10036 (212) 278-0400

I hereby certify that this paper is being deposited this date with the U.S. Postal Service in first class mail addressed to Commissioner of Patent, P.O. Box 1450, Alexandria, VA 23313-1450.

Paul Teng
Reg. No. 40,837

Date
March 4, 2004

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

INFORMATION DISCLOSURE STATEMENT

Pursuant to the applicant's duty of disclosure, the information listed in the attached Form PTO-1449 is brought to the attention of the Examiner. A copy of the information identified herein is also provided.

It is respectfully requested that the information cited in annexed Form PTO-1449 be considered by the Examiner in connection with the above-identified patent application, filed concurrently herewith, and that such art be made of record in said application.

The citation of the listed items is not a representation that they constitute a complete or exhaustive listing of the relevant art or that these items are prior art. The items listed are submitted in good faith, but are not intended to substitute for the Examiner's search. It is

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hoped, however, that in addition to apprising the Examiner of the particular items, they will assist in identifying fields of search and in making as full and complete a search as possible.

The filing of this Information Disclosure Statement is not an admission that the information cited herein is, or is considered to be, material to patentability as defined in 37 C.F.R. §1.56(b).

The Office is hereby authorized to charge any additional fees which may be required for consideration of this Information Disclosure Statement and to credit any overpayment to our Deposit Account No. 03-3125.

Early and favorable consideration of the case is respectfully requested.

Respectfully submitted,

Paul Teng, Reg. No. 40,837 Attorney for Applicant Cooper & Dunham LLP 1185 Avenue of the Americas New York, New York 10036 (212) 278-0400

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U.S. Department of Commerce Patent and Trademark Office

Atty. Docket No. 2271/71388

Serial No. 10/701,249

INFORMATION DISCLOSURE CITATION

sheets if necessary)

Junji ICHIMIYA

Filing Date:

Applicant:

November 04, 2003

Group Art Unit:

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FOREIGN PATENT DOCUMENTS

	Document Number					er			Date	Country	Class	Subclass	Translation	
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OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

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EXAMINER

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609: Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.